



1-21-05

IPW

First Named Inventor	Chun Chen	TRANSMITTAL FORM UNDER 37 CFR 1.10 (LARGE ENTITY)
Serial No.	10/602,324	
Filing Date	June 24, 2003	
Group Art Unit	2818	
Examiner Name	Dung A. Le	
Confirmation Number	1950	
Attorney Docket No.	400.211US01	
Title: METHODS OF FORMING MEMORY CELLS HAVING SELF-ALIGNED SILICIDE (as amended)		

Mail Stop: AMENDMENT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Enclosures					
The following documents are enclosed:					
<input checked="" type="checkbox"/>	Response to Non-Final Office Action (15 pgs.);				
<input checked="" type="checkbox"/>	a return postcard.				
Please charge any additional fees or credit any overpayments to Deposit Account No. 501373.					
<u>CUSTOMER NUMBER 27073</u>					
Leffert Jay & Polglaze, P.A. P. O. Box 581009 Minneapolis, MN 55458-1009					
Submitted By					
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Signature				Date	January 19, 2005
Certificate of Mailing					
"Express Mail" mailing label number: EV579604619US Date of Deposit: January 19, 2005 These papers and fees are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR §1.10 on the date indicated above and addressed to Mail Stop: AMENDMENT, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.					
(LARGE ENTITY TRANSMITTAL UNDER 37 C.F.R. 1.10)					

First Named Inventor	Chun Chen	<p style="text-align: center;">RESPONSE TO NON-FINAL OFFICE ACTION</p>
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In response to the non-final Office Action mailed December 7, 2004, please consider the following amendments and remarks:

IN THE TITLE

Please amend the Title to read:

METHODS OF FORMING MEMORY CELLS HAVING SELF-ALIGNED SILICIDE